

Notice of References Cited	Application/Control No. 09/995,696		Applicant(s)/Patent Under Reexamination WAKABAYASHI, TAKEFUMI	
	Examiner Sargon N. Nano		Art Unit 2157	Page 1 of 1

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*	B	US-6,714,971	03-2004	Motoyama et al.	709/219
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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